

<b>Notice of References Cited</b>	Application/Control No. 10/723,838	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Tan Ho	Art Unit 2821	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,839,033 B2	01-2005	Shimabara et al	343/702
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*	C	US-6,756,943 B2	06-2004	Kim et al.	343/702
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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